

	Class	Subclass
ISSUE CLASSIFICATION		

TO	I.P.E.	PATENT DATE
SCANNED <i>1034</i>	G.A. <i>SW</i>	

APPLICATION NO. 09/808790	CONT/PRIOR D	CLASS 025 438	SUBCLASS 000 691	ART UNIT 3729	EXAMINER Vinh
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APPLICANTS
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Duncan Robison

TITLE
Cluster tool systems and methods for processing wafers

PTO-2040
12/98

ISSUING CLASSIFICATION

<p>INTERNATIONAL REGISTERED</p>	<p>CLASS NO.</p>	<p>CLASSIFICATION</p>
<p><input type="checkbox"/> The term of this patent subsequent to _____ (date) has been extended.</p> <p><input type="checkbox"/> The term of this patent shall be extended beyond the original date of U.S. Patent No. _____</p>	<p><input type="checkbox"/> The constant _____ character of this patent has been established.</p>	<p>NOTES FOR INFORMATION FILED</p>
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(FACE)